

10/552476

JC09 Rec'd PCT/PTO 07 OCT 2009

Docket No.: 679-008

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Brian Charles Hilton STEELE *et al.*

U.S. Patent Application No. -----

Filed: *herewith*

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: Confirmation No. -----
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: Group Art Unit: -----
:
: Examiner: -----

For: DENSIFICATION OF CERIA BASED ELECTROLYTES

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

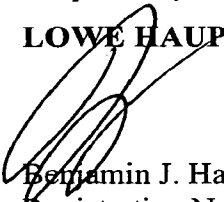
Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Respectfully submitted,

LOWE HAUPTMAN & BERNER, LLP


Benjamin J. Hauptman
Registration No. 29,310

1700 Diagonal Road, Suite 300
Alexandria, Virginia 22314
(703) 684-1111
Facsimile: (703) 518-5499
Date: October 7, 2005
BJH/ej

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Sheet 1 of 1

**INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION
(PTO-1449)**

ATTY. DOCKET NO.
679-008

U.S. APPLICATION NO.
Not yet assigned

APPLICANT
Brian Charles Hilton STEELE et al.

FILING DATE
herewith

GROUP

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
/CL/	1 000 913 A1	02/08/2001	EP			abstract	
/CL/	1 254 862 A2	11/06/2002	EP				
/CL/	03/075382 A2	09/12/2003	WO				

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)			
/CL/	OISHI et al; "Stainless Steel Supported Thick Film IT-SOFCs for Operation at 500-600 degree C"; JOURNAL OF THE ELECTROCHEMICAL SOCIETY PROCEEDINGS; vol. 2002-21, 2002, pages 230-237; XP009032114		
EXAMINER	/Carlos Lopez/	DATE CONSIDERED	06/07/2010

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.